

**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 2823**



PATENT
Customer No. 22,852
Attorney Docket No. 04329.2622

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Gaku MINAMIHABA, et al.) Group Art Unit: 2823
)
Serial No.: 09/932,943) Examiner: Lee, Hsien Ming
)
Filed: August 21, 2001)
)
For: SLURRY FOR CHEMICAL)
MECHANICAL POLISHING AND)
METHOD OF MANUFACTURING)
SEMICONDUCTOR DEVICE)

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

REQUEST FOR RECONSIDERATION AFTER FINAL

In reply to the Final Office Action mailed September 16, 2004, with a period for response extending through February 16, 2005 by the attached Petition for Extension of Time of Two Months and requisite fee payment, Applicants request the Examiner's reconsideration in view of the remarks that follow:

Remarks begin on page 2 of this paper.

OK
to
enter
Lee
3/8/05